

<b>Notice of References Cited</b>	Application/Control No. 09/893,998	Applicant(s)/Patent Under Reexamination CEMIC ET AL.	
	Examiner Arnel C. Lavarias	Art Unit 2872	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2001/0033490 a1	10-2001	Koyama et al.	362/293
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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